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Geun Young Yeom is a professor of Materials Science & Engineering and SKKU Advanced Institute of Nanotechnology in SungKyunKwan University. He is the author of a book on “Plasma Etching Technology” written in Korean. His latest research focuses on the development of plasma-assisted processes and tools applied to nanoscale semiconductors and flat panel displays. For nanoscale semiconductors, he is working on neutral beam etching systems and atomic layer etching systems. He is also working on 2-D material processing such as MoS<sub>2</sub>, graphene, etc. He is currently vice presidents of Material Research Society-Korea, Korea Vacuum Society, and Korea Institute of Surface Engineering.